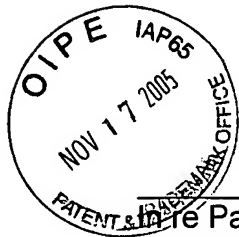


Express Mail No. EV522673038US



Docket No.: 291958110US2
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Patent Application of:
Hanson et al.

Allowed: August 22, 2005

Application No.: 10/721,057

Confirmation No.: 3252

Filed: November 24, 2003

Art Unit: 2877

For: SEMICONDUCTOR PROCESSING
APPARATUS HAVING LIFT AND TILT
MECHANISM

Examiner: M. P. Stafira

**COMMENTS ON STATEMENT OF REASONS
FOR ALLOWANCE UNDER 37 CFR §1.104(E)**

MS Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant has received the Examiner's Statement of Reasons for Allowance with the August 22, 2005 Notices of Allowance and Allowability regarding the above-identified application. Entry of the Statement into the record should not be construed as any agreement with or acquiescence in the reasoning stated by the Examiner. Each of the claims stands on its own merits and is patentable because of the combination it recites and not because of the presence or absence of any one particular element.

The Examiner's Statement was not prepared by Applicant and only contains the Examiner's possible positions in one or more reasons for allowability. Thus, any interpretation with respect to the Examiner's Statement of Reasons for Allowance should not be imputed to the Applicant.

Application No.: 10/721,057

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Applicant believes no fee is due with this response. However, if a fee is due, please charge our Deposit Account No. 50-0665, under Order No. 291958110US2 from which the undersigned is authorized to draw.

Dated: 16 November 2005

Respectfully submitted,

By 

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